

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Izumi FUSEGAWA et al.

Application No.: New U.S. National Stage of
PCT/JP03/05167

Filed: October 8, 2004

Docket No.: 121356

For: METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL, SILICON SINGLE
CRYSTAL AND SILICON WAFER**PRELIMINARY AMENDMENT**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;**Amendments to the Claims** as reflected in the listing of claims;**Remarks.**